

10-08-2002



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OVER SHEET

U.S. DEPARTMENT OF COMMERCE

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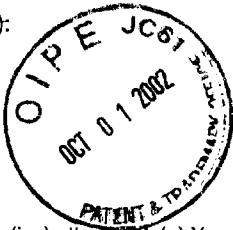
10.1.02

Patent and Trademark Office

To the Honorable Com.

and the attached original documents or copy thereof.

1. Name of conveying party(ies):

**Chong Wee Lim
Chan Soo Shin
Daniel Gall
Ivan Georgiev Petrov
Joseph E. Greene**

Additional name(s) of conveying party(ies) attached? () Yes (X) No

3. Nature of conveyance:

- (X) Assignment () Merger
() Security Agreement () Change of Name
() Other _____

Execution Date: 9/5/02; 9/16/02; 9/9/02; 9/5/02; and 9/9/02

2. Name and address of receiving party(ies)

Name: **The Board of Trustees of the University of Illinois**Internal Address: **352 Henry Administration Bldg.,**Street Address: **506 South Wright Street**City: **Urbana** State: **IL** ZIP: **61801**

Additional name(s) & address(es) attached: () Yes (X) No

4. Application number(s) or patent number(s): **10/226,101**

If this document is being filed together with a new application, the execution date of the application is:

A. Patent Application No.(s)

B. Patent No.(s)

Additional numbers attached? () Yes (X) No.

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: **Steven P. Fallon, Esq.
Greer, Burns & Crain, Ltd.**Internal Address: **300 South Wacker Drive
25th Floor
Chicago, Illinois 60606**

Street Address: _____

City: _____ State: _____ ZIP: _____

Additional name(s) & address(es) attached: () Yes (X) No

10/07/2002 TDI A21 00000103 10226101

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40.00 OP

6. Total number of applications and patents involved: **1**

7. Total fee (37 CFR 3.41) \$ 40.00

(X) Enclosed

(X) Authorized to be charged to deposit account only in the event proper payment is not enclosed.

8. Deposit account number:

07-2069

(Attach duplicate copy of this page if paying by deposit account)

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9. Statement and signature.

*To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.***Steven P. Fallon**

Name of Person Signing

Signature

September 25, 2002

Date

Total number of pages including cover sheet, attachments, and document: **7**

1201.66274

Mail documents to be recorded with required cover sheet information to:
Commissioner of Patents & Trademarks, Box Assignments
Washington, D.C. 20231

PATENT
REEL: 013353 FRAME: 0496

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ASSIGNMENT

464-1 Chunmindong, Expo Apt. 411-1701, Yuseong, Daejeon 305-762, Korea

WHEREAS, Chong Wee Lim, a citizen of Malaysia, residing at 308 N. Orchard Street, Apt. No. 14, Urbana, IL 61801, Chan Soo Shin, a citizen of the Republic of Korea, residing at ~~2217 Philo Road, Urbana, IL 61802~~, Daniel Gall, a citizen of Switzerland, residing at 1100 Willard Street, Urbana, IL 61801, Ivan Georgiev Petrov, a citizen of Bulgaria, residing at 2314 Southmoor Drive, Champaign, IL 61821, and Josphe E. Greene, a citizen of the United States of America, residing at 906 S. Lynn Street, Champaign, IL 61820, hereinafter referred to as ASSIGNORS, have invented and own a certain invention entitled:

**METHOD FOR FORMING AN EPITAXIAL COBALT
SILICIDE LAYER ON MOS DEVICES**

for which application for Letters Patent of the United States has been filed on August 22, 2002, and accorded Serial No. 10/226,101;

WHEREAS, THE BOARD OF TRUSTEES OF THE UNIVERSITY OF ILLINOIS, a not-for-profit corporation of the State of Illinois having a place of business at 352 Henry Administration Building, 506 South Wright Street, Urbana, Illinois 61801, hereinafter referred to as ASSIGNEE, is desirous of acquiring the entire interest in, to and under said invention and any United States Letters Patent to be obtained therefor:

NOW, THEREFORE, TO ALL WHOM IT MAY CONCERN:

Be it known that in consideration of the payment by ASSIGNEE TO ASSIGNORS of the sum of One Dollar (\$1.00), the receipt of which is hereby acknowledged, and for other good and valuable consideration, ASSIGNORS hereby sell, assign and transfer to ASSIGNEE the full and exclusive right, title and interest to said invention and all Letters Patent of the United States to be obtained therefor on said application or any continuation, division, renewal, substitute or reissue thereof for the full term or terms for which the same may be granted.


ASSIGNORS also assign all of its right, title and interest in and to said invention in all foreign countries, and all applications for Letters Patent which may evolve therefrom, including the right to claim International Convention priority.

ASSIGNORS hereby covenant that no assignment, sale, agreement or encumbrance has been or will be made or entered into which would conflict with this assignment and sale.

**METHOD FOR FORMING AN
EPITAXIAL COBALT SILICIDE
LAYER ON MOS DEVICES
Filed: August 22, 2002**

ASSIGNORS further covenant that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said application, said invention and said Letters Patent as may be known and accessible to ASSIGNORS and ASSIGNORS will testify as to the same in any interference or litigation related thereto and will promptly execute and deliver to ASSIGNEE or its legal representative any and all papers, instruments or affidavits required to apply for, obtain, maintain and enforce said application, said invention and said Letters Patent which may be necessary or desirable to carry out the purposes hereof.

Date 09/05/02



Chong Wee Lim

State of Illinois

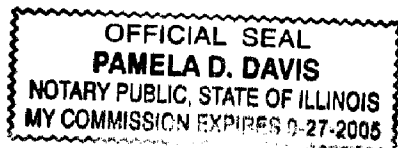
)
) ss:

County of Champaign

)

I hereby certify that Chong Wee Lim before me personally appeared and acknowledged that the foregoing Assignment was duly signed, sealed and delivered by him as his free and voluntary act on this 05 day of September, 2002.

(Notarial Seal)



Notary Public Pamela D. Davis
My commission expires: September 27, 2005

METHOD FOR FORMING AN
EPITAXIAL COBALT SILICIDE
LAYER ON MOS DEVICES
Filed: August 22, 2002

Date 9-16-2002

Chan Soo Shin
Chan Soo Shin

State of _____)

) ss:

County of _____)

I hereby certify that Chan Soo Shin before me personally appeared and acknowledged that the foregoing Assignment was duly signed, sealed and delivered by him as his free and voluntary act on this 16 day of September, 2002.

SANGKYUN PARK Sangkyun Park 9/16/02

(Notarial Seal)

Notary Public

My commission expires:

METHOD FOR FORMING AN
EPITAXIAL COBALT SILICIDE
LAYER ON MOS DEVICES
Filed: August 22, 2002

Date 9/9/02

D. Gall
Daniel Gall

State of NY

)

) ss: 318-92-8615

County of ~~West~~ Albany

)

I hereby certify that Daniel Gall before me personally appeared and acknowledged that the foregoing Assignment was duly signed, sealed and delivered by him as his free and voluntary act on this 9th day of September, 2002.

(Notarial Seal)

Eleanor F. Meyer

Notary Public

My commission expires: March, 30, 2003

ELEANOR F. MEYER

Notary Public, State of New York

Residing in Albany County

Commission Expires Mar. 30, 192003

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METHOD FOR FORMING AN
EPITAXIAL COBALT SILICIDE
LAYER ON MOS DEVICES
Filed: August 22, 2002

Date 08.05.2002

Ivan Petrov
Ivan Georgiev Petrov

State of _____

)

) ss:

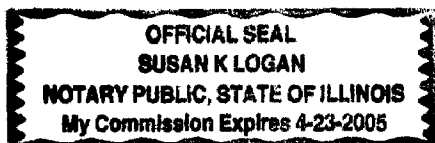
County of _____

)

I hereby certify that Ivan Georgiev Petrov before me personally appeared and acknowledged that the foregoing Assignment was duly signed, sealed and delivered by him as his free and voluntary act on this 5 day of September, 2002.

(Notarial Seal)

Notary Public Susan K. Logan
My commission expires: 4-23-2005



METHOD FOR FORMING AN
EPITAXIAL COBALT SILICIDE
LAYER ON MOS DEVICES
Filed: August 22, 2002

Date 9/9/02

Joseph E. Greene
)
) ss:
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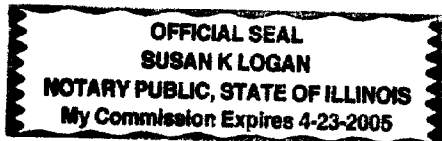
State of Illinois

County of Champaign

I hereby certify that Joseph E. Greene before me personally appeared and acknowledged that the foregoing Assignment was duly signed, sealed and delivered by him as his free and voluntary act on this 9th day of September, 2002.

(Notarial Seal)

Notary Public Susan K. Logan
My commission expires: 4-23-2005



METHOD FOR FORMING AN
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